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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Masahiro FURUSAWA et al.

Application No.: 10/028,712

Filed: December 28, 2001

Docket No.: 111604

Patent No.: 6,846,513

Issue Date: January 25, 2005

For: METHOD FOR FABRICATING A SILICON THIN-FILM

**PETITION UNDER 37 C.F.R. §1.183 FOR  
WAIVER OF THE REQUIREMENTS OF 37 C.F.R. §3.81**

Director of the U.S. Patent and Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This petition respectfully requests waiver of the requirements of 37 C.F.R. §3.81 so that a Certificate of Correction can be granted to correctly identify the assignees on the face of the patent.

The above-identified patent is assigned to Seiko Epson Corporation and JSR Corporation, by virtue of an Assignment recorded on April 22, 2002 at Reel 012819, Frame 0032. The Assignment was submitted for recordation prior to payment of the Issue Fee, but the second assignee was inadvertently omitted from box 3 of the Issue Fee Transmittal when paying the Issue Fee.

Therefore, the incorrect assignee data was printed on the face of the patent when the assignee should be correctly identified as "Seiko Epson Corporation, Tokyo, Japan" and "JSR Corporation, Tokyo, Japan".

It is respectfully requested that the requirements of 37 C.F.R. §3.81 be waived, so Applicants can file a Request for Certificate of Correction to identify the correct assignees.

Attached to this petition are:

Repln. Ref: 07/26/2005 AKELLEY 0011211700  
DAH:150461 Name/Number:10028712  
FC: 9204 \$270.00 CR

06/30/2005 SDENBOB1 00000057 10028712

01 FC:1462

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Adjustment date: 07/26/2005 AKELLEY  
06/30/2005 SDENBOB1 00000057 10028712  
01 FC:1462

-400.00 OP

07/26/2005 AKELLEY 00000013 10028712

01 FC:1808

130.00 OP